

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Attn: APPLICATION BRANCH**
Koji MISHIMA et al. : Attorney Docket No. 2004_0611
Serial No. NEW :
Filed April 20, 2004 :

PLATING METHODAND PLATING
APPARATUS
(Rule 1.53(b) Divisional
of Serial No. 09/955,115,
Filed September 19, 2001)

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CLAIM OF PRIORITY UNDER 35 USC 119

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Sir:

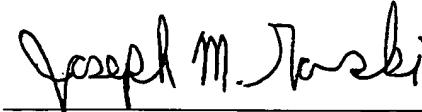
Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 2000-285740, filed September 20, 2000, Japanese Patent Application No. 2000-294665, filed September 27, 2000 and Japanese Patent Application No. 2001-248125, filed August 17, 2001, as acknowledged in the Declaration of this application.

Certified copies of said Japanese Patent Application are of record in parent application Serial No. 09/955,115, filed September 19, 2001.

Respectfully submitted,

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By



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